



Docket No. 740819-405  
Serial No. 09/630,680

#17/c  
4a  
6/10/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shinichi IMAI

Serial No. 09/630,680

Filed: August 1, 2000

For: "PLASMA PROCESSING METHOD"

- )
- ) Group Art Unit: 1765
- ) Examiner: Shamim Ahmed
- ) Confirmation No. 7497
- ) Date: June 3, 2003

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[37 CFR 1.8(a)]

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Mail Stop Fee Amendments, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on June 3, 2003.

Signature: Linda C. Haynes

Name: Linda C. Haynes

**AMENDMENT**

Mail Stop Fee Amendments  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed February 4, 2003, the due date for which having been extended one (1) month to June 4, 2003, please consider the remarks and amendments in connection with the above-identified application.